



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

ISHIKAWA et al.

Atty. Ref.: 461-153; Confirmation No. 6108

Appl. No. 10/705,883

TC/A.U. 3742

Filed: November 13, 2003

Examiner: Leung, Philip

For: METHOD AND APPARATUS FOR DRYING CERAMIC MOLDED ARTICLES

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April 4, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

Responsive to the Official Action dated November 10, 2005, kindly enter the following amendment and remarks.

ISHIKAWA et al.  
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**IN THE TITLE:**

~~METHOD AND APPARATUS FOR DRYING CERAMIC MOLDED ARTICLES~~ USING  
MICROWAVE ENERGY